



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Shinji Maekawa  
Serial No. : 09/724,403  
Filed : November 27, 2000  
Title : METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE WITH  
TENSILE STRESS (AS AMENDED)

Art Unit : 2813  
Examiner : Laura Schillinger  
Confirmation No.: 7575

**Mail Stop Amendment**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

RESPONSE TO RESTRICTION REQUIREMENT

Responsive to the action mailed November 30, 2005, applicant elects the invention of Species 5 drawn to the embodiment of Claims 61, 65-66 and 71 pertaining to a method including removing a tensile stressed material and forming a gate. The election is made without traverse.

Please apply any charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: \_\_\_\_\_

12/27/05

Roberto J. Devoto  
Reg. No. 55,108

Fish & Richardson P.C.  
1425 K Street, N.W.  
11th Floor  
Washington, DC 20005-3500  
Telephone: (202) 783-5070  
Facsimile: (202) 783-2331